



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
JAMES BROC STIRTON

Serial No.: 09/824,156

Filed: April 2, 2001

For: METHOD OF MEASURING IMPLANT
PROFILES USING SCATTEROMETRIC
TECHNIQUES

Group Art Unit: 2877

Examiner: Juan D. Valentin

Atty. Dkt. No.: 2000.071000/TT4354

#161 Declaration
Approved
4/29/03

DECLARATION UNDER 37 C.F.R. § 1.131 OF J. MIKE AMERSON

1. My name is J. Mike Amerson. I am a shareholder in the firm of Williams, Morgan & Amerson. I have personal knowledge of the facts stated herein.

2. I am the attorney within Williams, Morgan & Amerson that prepared and filed application Serial no. 09/824,156, entitled "Method of Measuring Implant Profiles Using Scatterometric Techniques."

3. On November 13, 2000, I received a request from AMD's legal department to prepare a United States patent application for the invention described in invention disclosure form number TT4354. See Exhibit A. The invention disclosure form is signed by James Broc Stirton, and it is dated November 3, 2000.

4. At some point after November 13, 2000, I reviewed the invention disclosure form number TT4354, discussed the invention with the inventor identified thereon, James Broc Stirton, and began preparing the patent application for the invention described in the invention disclosure form.

5. On January 23, 2001, I sent an initial draft of the application to James Broc Stirton for review. See Exhibit B.

6. At some time after January 23, 2001, I received comments from the inventors regarding the initial draft application. To the extent necessary, I revised the application.

7. On March 7, 2001, I sent a revised copy of the application along with formal papers (assignment, declaration and power of attorney) to the inventor James Broc Stirton for review and the possible execution of the formal papers. See Exhibit C.

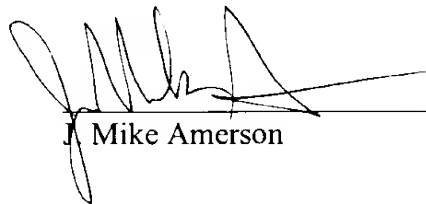
8. The formal papers for the application were signed on March 26, 2001 by the inventor James Broc Stirton.

9. I filed the application on April 2, 2001, with the United States Patent and Trademark Office via Express Mail.

10. I understand that willful false statements and the like so made are punishable by fine or imprisonment, or both, and may jeopardize the validity of the application or any patent issuing thereon.

11. I declare under penalty of perjury that the foregoing is true and correct.

Date: March 21, 2003


Mike Amerson

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Atty. Dkt. No.: 2000.071000/TT4354

DECLARATION UNDER 37 C.F.R. § 1.131 OF JAMES BROC STIRTON

1. My name is James Broc Stirton. I have personal knowledge of the facts stated herein.

2. I am currently employed with Advanced Micro Devices, Inc. in Austin, Texas. I am a named inventor on application Serial No. 09/824,156 entitled "Method of Measuring Implant Profiles Using Scatterometric Techniques."

3. Attached as Exhibit A is a copy of the invention disclosure form I prepared in Austin, Texas for the invention described in the above-referenced patent application. I prepared and signed the invention disclosure form on or before November 3, 2000, as indicated by the date stamp.

4. The attached invention disclosure form was provided with internal tracking number TT4354 by AMD's legal department, and it was sent to the law firm of Williams, Morgan & Amerson on or about November 10, 2000, with a request to prepare a United States patent application for the invention disclosed in the invention form.

5. I understand that willful false statements and the like so made are punishable by fine or imprisonment, or both, and may jeopardize the validity of the application or any patent issuing thereon.

6. I declare under penalty of perjury that the foregoing is true and correct.

3/18/03
Date

James Broc Stirton
James Broc Stirton